

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
Ju-Cheol SHIN et al. : Attn: Applications Branch
Serial No. (New) : Attorney Docket No. SEC.828D
Filed: June 24, 2003 :

For: CHEMICAL VAPOR DEPOSITION METHOD FOR DEPOSITING SILICIDE AND
APPARATUS FOR PERFORMING THE SAME

INFORMATION DISCLOSURE STATEMENT
(SUBMISSION WITH CONTINUATION-IN-PART OR
RULE 1.53(b) CONTINUATION OR DIVISIONAL APPLICATION)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an
Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications or other information submitted for consideration by the
Office are listed on PTO-1449 form(s), attached hereto.

II. REFERENCES PREVIOUSLY CITED OR SUBMITTED

Pursuant to 37 C.F.R. § 1.98(d), consideration of information listed on the PTO-1449
form(s) is requested since any patents, publications or other information which are listed
on the PTO-1449 form(s) but for which copies are not enclosed herewith, were previously
cited by or submitted to the PTO in one of the following applications which has been relied
upon for an earlier filing date under 35 U.S.C. § 120:

U.S. Serial Number

U.S. Filing Date

09/884,993

June 21, 2001

III. FEES

This Information Disclosure Statement is being filed concurrent with the filing of a continuation-in-part, continuation or divisional patent application; therefore, no fee is required.

If the Examiner has any questions concerning this IDS or requires a copy of any of the references cited but not provided, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 50-0238.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 50-0238 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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Dated: June 24, 2003

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
SEC.828D

Application Number
NEW

Applicant(s)
Ju-Cheol SHIN et al.

Filing Date
June 24, 2003

Group Art Unit
TBA

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	6,221,771	04/2001	Ban et al.			
	B	5,923,988	07/1999	Cheng et al.			
	C	5,780,360	07/1998	Tseng et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	D	JP7086253	03/31/1996	JAPAN				
	E	JP60237265 A	11/1985	JAPAN				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.